Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/735,024	IKUTA ET AL.	
Examiner	Art Unit	
Ephrem Alemu	2821	

SEARCHED			
Class	Subclass	Date	Examiner
343	700MS, 702, 767, 846, 895	2/25/2005	EΑ
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH NOT (INCLUDING SEARCH		·)
	DATE	EXMR
Reviewed US Patent No. 6,806,832 & Appl. No. 10/724,579 for Double patenting issue	2/25/2005	EA
EAST	3/5/2005	EA
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